

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Sung-Jin KIM, et al.

Serial No.: 10/685,655 Examiner: Vu, Hung K.

Filed: October 14, 2003 Group Art Unit: 2811

Confirmation No.: 5662

For: PHOTO MASK SET FOR FORMING MULTI-LAYERED  
INTERCONNECTION LINES AND SEMICONDUCTOR DEVICE  
FABRICATED USING THE SAME

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

This paper is responsive to the non-final Office Action (Paper No. 052006) that was mailed on 5 June 2006.

**Claim Amendments** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.